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2823

TRANSMITTAL LETTER			Case No. 10519-29
Serial No. 509/918,853	Filing Date JULY 30, 2001	Examiner F. TOLEDO	Group Art Unit 2823
Inventor(s) & YVODA ET AL.			
Title of Invention PROCESS FOR FABRICATING A DIELECTRIC FILM USING PLASMA OXIDATION			

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is Transmittal Letter (in duplicate); Petition and Fee for Extension of Time (in duplicate); Amendment and Record of Interview (28 pages); \$1548 Check; \$110 Check; and Postcard Receipt.

- Small entity status of this application under 37 CFR § 1.27 has been established by verified statement previously submitted.
- A verified statement to establish small entity status under 37 CFR §§ 1.9 and 1.27 is enclosed.
- Petition for a 1 month extension of time.
- No additional fee is required.
- The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest No. Previously Paid For	Present Extra
Total		Minus		58
Indep.		Minus		6
First Presentation of Multiple Dep. Claim				

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Small Entity		or	Other Than Small Entity	
Rate	Add'l Fee		Rate	Add'l Fee
x \$9=			x \$18=	1044
x 42=			x \$84=	504
+\$140=			+\$280=	
		Total add'l fee	\$	Total add'l fee
				\$1548

- Please charge Deposit Account No. 23-1925 (BRINKS HOFER GILSON & LIONE) in the amount of \$ \_\_\_\_\_. A duplicate copy of this sheet is enclosed.
- Checks in the amount of \$1548 and \$110 to cover the petition and additional claims fees are enclosed.
- The Commissioner is hereby authorized to charge payment of any additional filing fees required under 37 CFR § 1.16 and any patent application processing fees under 37 CFR § 1.17 associated with this communication or credit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.
- I hereby petition under 37 CFR § 1.136(a) for any extension of time required to ensure that this paper is timely filed. Please charge any associated fees which have not otherwise been paid to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

JOSEPH F. HETZ  
Registration No. 41,070  
Attorney for Applicant

BRINKS HOFER GILSON & LIONE  
P.O. BOX 10395  
CHICAGO, ILLINOIS 60610  
(312) 321-4200

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on August 22, 2003.

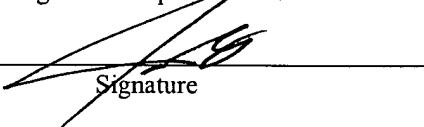
Date: August 22, 2003 Signature:

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Joseph F. Hetz - Reg. No. 41,070  
Name of Applicant, Assignee or  
Registered Representative  
  
Signature

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Patent  
Our Case No. 10519-29

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Vyvoda et al. )  
Serial No.: 09/918,853 ) Examiner: F. Toledo  
Filed: July 30, 2001 ) Group Art Unit: 2823  
For: Process for Fabricating a Dielectric )  
Film Using Plasma Oxidation )

**AMENDMENT**  
**AND**  
**RECORD OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the Office Action  
mailed April 23, 2003.

08/27/2003 WASFAH1 00000105 09918853

02 FC:1201 504.00 OP  
03 FC:1202 1044.00 OP